

#4 TOS KDUNCAN 11-19 ()1

862.C2151

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) · Es	caminer: UNASSIGNED			
MASAYA OGURA, ET AL.)				
Application No.: 09/811,419		: Gi)	roup Art Unit: 1756			
Filed: March 20, 2001		·)		Ħ		,
For:	EXPOSURE APPARATUS, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES AND PLANT THEREOF	,	Tune 25, 2001	ECHNOLOGY CENTER	JUN 28 200	ZE CE I VE L
Commissioner for Patents				R 1700		<u> </u>
Washington, D.C. 20231				5		

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

Japanese patent document No. 6-20927 has been discussed on page 4 of the subject specification and corresponds to U.S. Patent No. 5,164,974.

Applicants request that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

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